

**Notice of References Cited**

Application/Control No.

09/836,191

Applicant(s)/Patent Under

Reexamination

CHEN, TSUNG-CHIH

Examiner

Chen-Wen Jiang

Art Unit

3744

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2,928,253-A	03-1960	Lopp et al.	62/3.3
	B	US-3,236,056-A	02-1966	Phillips et al.	62/3.6
	C	US-4,448,028-A	05-1984	Chao et al.	62/3.2
	D	US-5,070,701-A	12-1991	Saeki et al.	62/3.1
	E	US-5,255,520-A	10-1993	O'Geary et al.	62/3.2
	F	US-5,544,487-A	08-1996	Attey et al.	62/3.7
	G	US-5,921,088-A	07-1999	Imaizumi et al.	62/3.4
	H	US-5,931,001-A	08-1999	Watanabe et al.	62/3.7
	I	US-6,003,319-A	12-1999	Gilley et al.	62/3.7
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.